

REPLY UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
ART UNIT 3689

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Yu Jen CHEN et al. § Atty Docket No.: 24061.104 / 2003-0457
Serial No. 10/829,490 § Customer No.: 42717
Filed: April 22, 2004 § Group Art Unit: 3689
For: Method Of Estimating The Impact On § Examiner: Long, Fonya M.
Potential Customers Of A Revision In § Confirmation No.: 6912
A Semiconductor Technology Process §

Commissioner for Patents
Mail Stop Amendment AF
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Final Office Action dated July 23, 2009, entry of the following amendments and comments into the record of the above-identified application is respectfully requested. No additional fees are believed to be due in connection with this filing. Should any additional fees be required, including extension of time fees, please charge any such fees to Haynes and Boone, LLP Deposit Account No. 08-1394.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.